

Application Data Sheet

IC/368147

IP20030100 19 FEB 2006

Inventor Information

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Citizenship Country: Japan

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38834

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Application Information

Title Line One: POLISHING SLURRY FOR SEMICONDUCTOR PLANARIZATION

Total Drawing Sheets: 1

Docket Number: 062110

Application Type: Utility

Representative Information

Customer No.: 38834

Domestic Priority Information

This application is a: National Stage of

Application One: PCT/JP2004/011549

Filing Date: August 11, 2004

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Foreign Priority Information

Foreign Application One: P2003-293438

Filing Date: August 14, 2003

Country: Japan

Priority Claimed: Yes

Assignee Information

Name of Assignee: HITACHI CHEMICAL CO., LTD.

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